

Docket Number: 071469-0307558
Client Reference: ES-038

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of

FUMIHIKO HIGUCHI

Group Art Unit:

Application No.:

Examiner:

Filed: March 30, 2004

Confirmation No.:

For: PROCESSING SYSTEM AND METHOD FOR TREATING A SUBSTRATE

INFORMATION DISCLOSURE STATEMENT

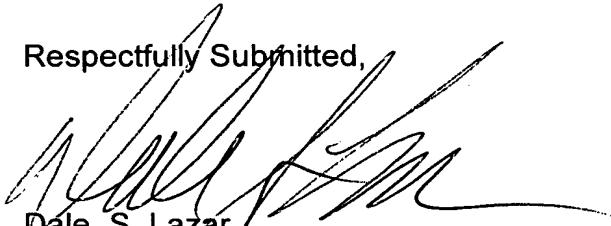
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

This application is one of a series of related applications, identified in the attached Appendix, which are directed to related technical subject matter. The identification of those U.S. Patent Applications is not to be construed as a waiver of secrecy as to those applications now or upon issuance of the present application as a patent. The Examiner is respectfully requested to consider the cited applications and the art cited therein during examination.

As this Information Disclosure Statement is being filed with the application, no fee is required.

Respectfully Submitted,



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APPENDIX

Examiner's Initials	First Inventor	Application No.	Filing Date	Enclosed
	HAMELIN	10/705,201	11/12/03	<input checked="" type="checkbox"/> Specification <input type="checkbox"/> Drawings
	HAMELIN	10/705,200	11/12/03	<input checked="" type="checkbox"/> Specification <input type="checkbox"/> Drawings
	HAMELIN	10/704,969	11/12/03	<input checked="" type="checkbox"/> Specification <input type="checkbox"/> Drawings
	WALLACE	10/705,397	11/12/03	<input checked="" type="checkbox"/> Specification <input type="checkbox"/> Drawings

The Examiner's initials indicates he/she has considered the cited application relative to the subject application.

DO NOT PRINT the above information on the patent which results from the subject application.